



TECHNICAL DATA



Microwave Relaxometer MWR-2S-3 Lifetime mapping tester for silicon ingots

Microwave Relaxometer MWR-2S-3 is the device for non-equilibrium charge carrier lifetime contactless determination in square silicon ingots and wafers by measuring photoconductivity decay constant after pulse photoexcitation of non-equilibrium charge carriers.

The MWR-2S-3 can be used for inspection of singleand polycrystalline silicon ingots and wafers for solar cell manufacture, quality of wafer processing in solar cell production line.

Parameter	Nominal	Accurac
Laser Light Dio de Radiation:		
Wavelength	975 nm	
Power in measurement area adjustment range	(50 ÷ 500) mW	± 30
Pulse width adjustment range	(2 ÷ 64) μs	
Microwave Generator Operation Frequency,	10 GHz	0.5
Specimen dimensions rang		
-width	< 210 mm	
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-length	(160 ÷ 300) mm	
Minimal measurement step	1 mm	
Measurable Specimen Resistivity Range	(0,5 ÷ 12) Ω.cm:	
Mains	~230 V (50÷60) Hz	± 10V
Power Consumption (excluding PC and monitor consumed power)	≤ 100 W	
Dimensions, mm	365 x 645 x 565	
Weight	30 kg	

